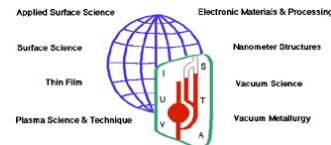




Associazione Italiana del Vuoto

June 28 - July 2, 2004
Cinema Festival Palace
Venice, Italy



IUVSTA

IVC-16 (16th International Vacuum Congress)

ICSS-12 (12th International Conference on Solid Surfaces)

NANO-8 (8th International Conference on Nanometer Scale Science and Technology)

AIV-17 (17th Vacuum National Symposium)

Registration Form

| | | |
|---|-------------------------|----------------------|
| First Name | Initial | Last Name |
| <input type="text"/> | <input type="text"/> | <input type="text"/> |
| Job Title | | |
| <input type="text"/> | | |
| Organization/University Affiliation | | |
| <input type="text"/> | | |
| Street Address | First Name | |
| <input type="text"/> | <input type="text"/> | |
| City | Zip Code | |
| <input type="text"/> | <input type="text"/> | |
| Country | Telephone Number | |
| <input type="text"/> | <input type="text"/> | |
| Fax Number: _____ E-mail (required): _____ | | |
| If eligible for a student fee , please check the box below and insert your tutor e-mail address. | | |
| Eligible? <input type="checkbox"/> | Tutor e-mail: _____ | |

Please, mark the Course(s) you plan to attend

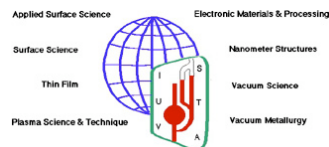
- Applied Vacuum Technology: Vacuum Physics and Technology
- Applied Vacuum Technology: Leak Detection
- Vacuum Insulating Panels
- An Introduction to Ellipsometry
- Nanotribology and Nanomechanics
- X-Ray Photoelectron Spectroscopy
- Local Structure by Soft X-Ray Absorption and Photoemission
- Auger Electron Spectroscopy and Depth-Profiling
- SIMS: Secondary Mass Spectrometry and Applications
- Thin Film Nucleation, Growth & Microstructure Evolution
- Elements of Micro- and Nano-Fabrication
- Hard Coatings
- High-*k* Dielectrics
- Introduction to Scanning Electron Microscopy
- Plasma Modifications of Polymers and Applications
- Degassing of Vacuum Materials and Its Reduction

Please, remember to explicitly indicate your first name and family name in the form used for the money bank transfer

Registrations forms submitted without proper payment will not be processed
Please note that any bank transfer fee will be charged to the participants



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| | |
|---|--------------------------------|
| Pre-Registration | (before April 20, 2004) |
| Full Week Fee | 480 Euro |
| Student Fee | 200 Euro |
| One Day (please circle day) | 250 Euro |
| A) Monday B) Tuesday C) Wednesday D) Thursday E) Friday | |
| Single Short Course | 480 Euro |
| Each Additional Course | 240 Euro |
| Conference + Short Course(s) | 480 + 240 (each) Euro |
| Student Conference Fee + Short Course(s) | 200 + 240 (each) Euro |
| Late Registration | (after April 20, 2004) |
| Full Week Fee | 580 Euro |
| Student Fee | 250 Euro |
| One Day (please circle day) | 280 Euro |
| A) Monday B) Tuesday C) Wednesday D) Thursday E) Friday | |
| Single Short Course | 580 Euro |
| Each Additional Course | 290 Euro |
| Conference + Short Course(s) | 580 + 290 (each) Euro |
| Student Conference Fee + Short Course(s) | 250 + 290 (each) Euro |
| Total Amount Paid | _____ Euro |

Method of Payment

Bank transfer to AIV account:

Associazione Italiana del Vuoto
Account Number 052848339610
Banca Sella
Agenzia 5
Viale Piave 4
20100 Milano, Italy
ABI Code 03268
CAB Code 01605
CIN Code P
Country Code IT30
IBAN Code IT30P0326801605052848339610
Swift Code SELBIT2B

Please send registration form and copy of the bank transfer receipt by mail or fax to:

Congress Office
INFM Headquarters
Corso Perrone 24
I-16152 Genoa, Italy
FAX: +39-010-65987-77
E-mail: ufficiocongressi@infm.it

Please, remember to explicitly indicate your first name and family name in the form used for the money bank transfer

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